

Notice of References Cited	Application/Control No. 10/825,673		Applicant(s)/Patent Under Reexamination ENDO ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-4,887,107	12-1989	Nakamura et al.	396/75
*	C	US-6,978,089 B2	12-2005	Nomura et al.	396/75
*	D	US-4,597,657	07-1986	Wakabayashi, Hiroshi	396/75
*	E	US-4,971,441	11-1990	Damlin et al.	356/338
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	L	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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